



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **YAMAMOTO Hajime et al.**

Group Art Unit: **1752**

Serial Number: **09/940,665**

Examiner: **THORNTON, YVETTE C**

Filed: **August 29, 2001**

P.T.O. Confirmation No.: **4795**

For: **CHEMICALLY AMPLIFIED RESIST COMPOSITION AND METHOD
FOR FORMING PATTERNED FILM USING SAME**

AMENDMENT UNDER 37 CFR §1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

December 11, 2003

Sir:

In response to the Office Action dated June 17, 2003, the response due date extended to December 17, 2003 by a 3-months Extension of Time, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 6 of this paper.

Remarks begin on page 14 of this paper.